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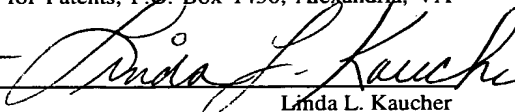
**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Michel J. Adrien Baillargeon      Examiner: David A. Vanore  
Serial No.: 10/681,947      Atty. Dkt. No.: 2003P15605US  
Filed: October 09, 2003      Art Unit No.: 2881  
Title: Method and Apparatus for Detecting Low-Mass Ions

**Certificate Of Mailing Pursuant To 37 CFR §1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

8/13/05   
Date Linda L. Kaucher

**LETTER TO OFFICIAL DRAFTSPERSON**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to M.P.E.P. Section 608.02, enclosed please find four sheets of formal drawings in the referenced case.

If there are any informalities with these drawings, Applicant requests issue of Form PTO-948 identifying the informalities noted by the Official Draftsperson.

The Commissioner is authorized to charge any fees in connection with this paper to Deposit Account No. 19-2179.

Respectfully submitted,



Jose R. de la Rosa  
Reg. No. 34,810

Date: 8-3-05

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